

PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

February 27, 2004

Applicant(s) : Yutaka MIYAMOTO et al.

For : METHOD AND APPARATUS FOR PRODUCING MOLD

Serial No. : Unknown Group: Unknown

Confirmation No.: Unknown

Filed : Unknown Examiner: Unknown

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P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

U.S. Patent Application Serial No. 10/009 903 is the parent of the above-identified divisional application. In compliance with the provisions of Rules 1.97(b)(1) and 1.98, enclosed herewith is Form PTO-1449. Pursuant to MPEP §609, copies of the cited references are not supplied since they may be found in the parent application.

Further consideration is respectfully solicited.

Respectfully submitted,

TFC/T/cc


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Applicant: Yutaka MIYAMOTO et al.
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U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Date	Name	Class	Sub Class	Filing Date
	AA	5 277 529	01/1994	Anders et al.		
	AB					
	AC					
	AD					
	AE					
	AF					

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Sub Class	Translation Yes No
	AG	EP 0838305 A1	04/1998	Europe		
	AH	102518	02/1926	Germany		
	AI	DD 295108 A5	10/1991	Germany		
	AJ	DE 19745471 A1	05/1998	Germany		
	AK	57-184654	11/1982	Japan		
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	AM	5-285783	11/1993	Japan		
	AN	10-156664	06/1998	Japan		
	AO	11-28640	02/1999	Japan		
	AP	WO 90/15684	12/1990	WIPO		

OTHER DOCUMENTS (Including Author, Title, Date, Pages, Etc.)

	AR	
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EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.